

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Micron Technology, Inc.  
Mail Stop 525  
8000 S. Federal Way,  
Boise, ID 83716-9632



Docket No.: M4065.0316/P316-A  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Gurtej Sandhu, et al.

Examiner: Alexander G. Ghyka

Application No.: 10/684,431

Art Unit: 2812

Filed: October 15, 2003

For: SEMICONDUCTOR DEVICES USING  
ANTI-REFLECTIVE COATINGS

**RESPONSE TO STATEMENT CONCERNING ALLOWABLE SUBJECT MATTER**

Commissioner for Patents  
MS: Amendment  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This paper is in filed in response to the Allowable Subject Matter section of the January 31, 2006 Notice of Allowability mailed by the PTO.

While the applicant is in general agreement with the allowable subject matter section, the applicant notes the examiner left out the word "layer" from the statement. In other words the Notice of Allowability stated that "the prior art does not anticipate or make obvious an oxide formed" and should read "the prior art does not anticipate or make obvious an oxide layer formed."

Application No.: 10/684,431

Docket No.: M4065.0316/P316-A

Dated: May 01, 2006

Respectfully submitted,

By 

Thomas J. D'Amico

Registration No.: 28,371

Steven War

Registration No.: 48,024

DICKSTEIN SHAPIRO MORIN &

OSHINSKY LLP

2101 L Street NW

Washington, DC 20037-1526

(202) 785-9700

Attorneys for Applicants